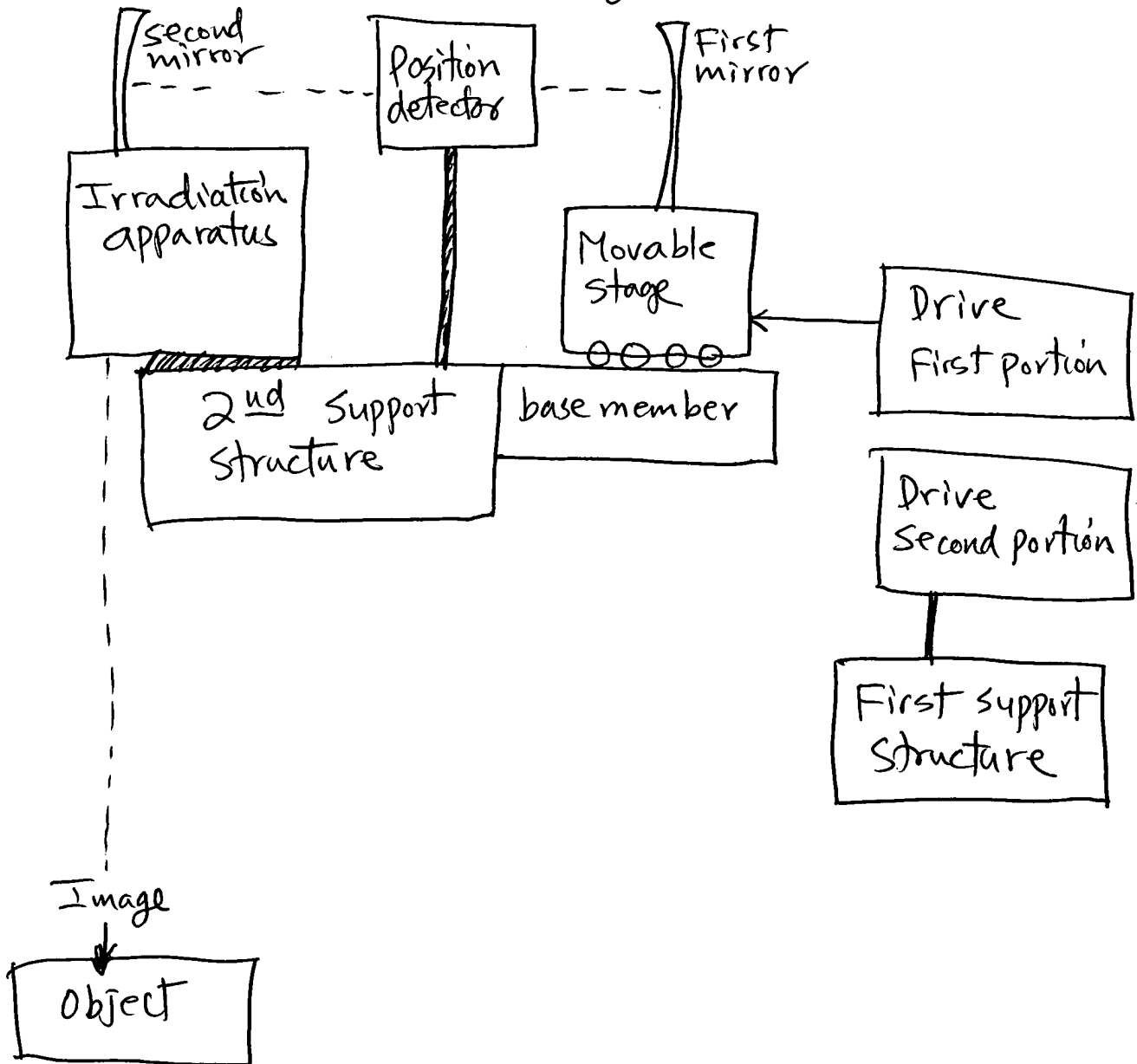


	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	5353	(lithograph\$2 or microlithograph\$2 or micro-lithograph\$2).a b.	USP AT	2004/08/ 12 15:07	
2	BRS	L2	1790 3	interferomet\$4	USP AT	2004/08/ 12 15:07	
3	BRS	L3	8413 1	irradiation	USP AT	2004/08/ 12 15:08	
4	BRS	L4	2770 59	mirror\$2	USP AT	2004/08/ 12 15:08	
5	BRS	L5	57	1 and 2 and 3 and 4	USP AT	2004/08/ 12 15:09	
6	BRS	L6	5131 32	stage	USP AT	2004/08/ 12 15:09	
7	BRS	L7	49	5 and 6	USP AT	2004/08/ 12 15:10	

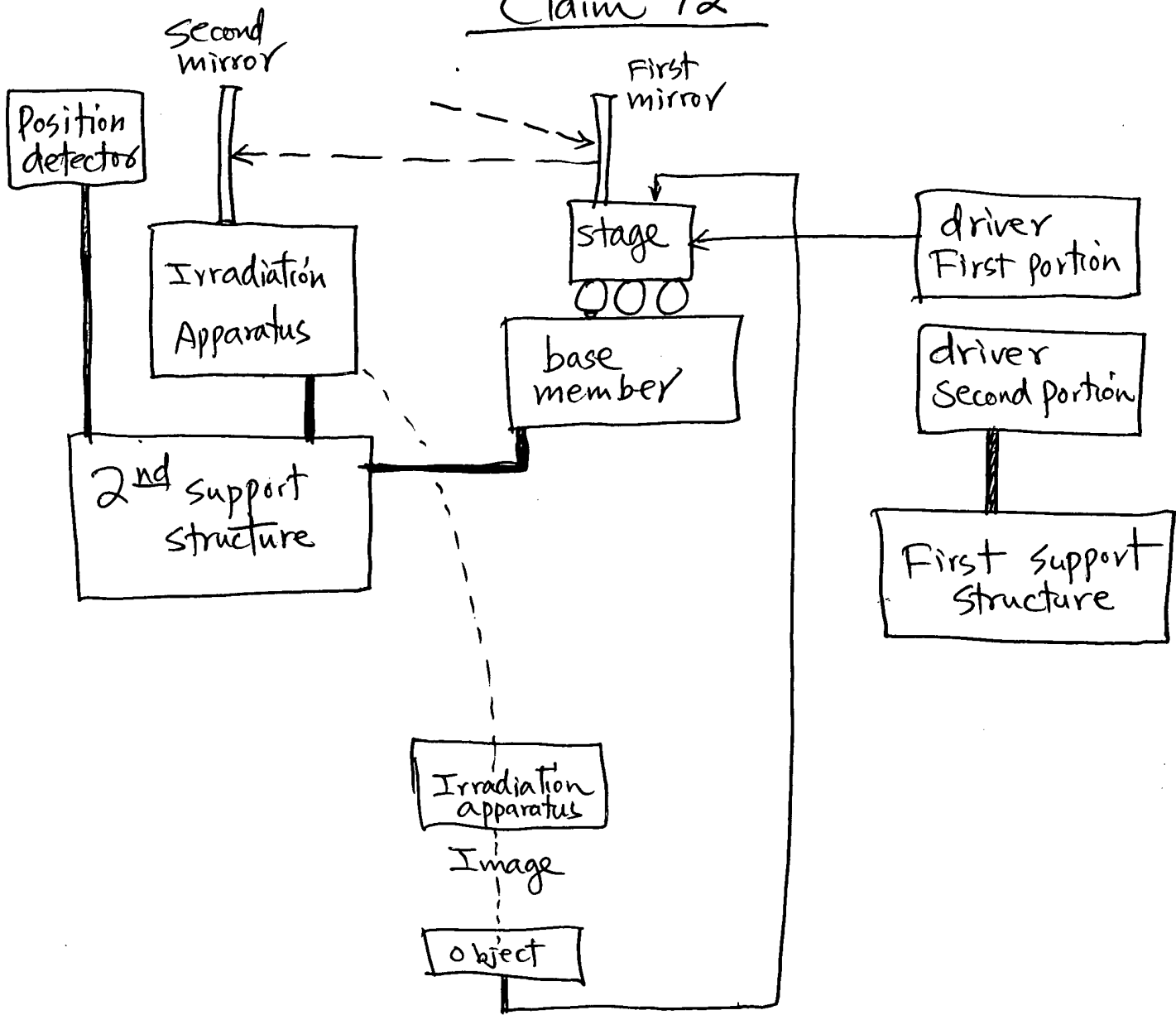
	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	42354	wafer and mask	USP AT	2004/08/ 12 15:29	
2	BRS	L2	513132	stage	USP AT	2004/08/ 12 15:29	
3	BRS	L3	277059	mirror\$2	USP AT	2004/08/ 12 15:29	
4	BRS	L4	15707	position adj2 detector	USP AT	2004/08/ 12 15:30	
5	BRS	L5	864236	drive or driver	USP AT	2004/08/ 12 15:30	
6	BRS	L6	176	1 and 2 and 3 and 4 and 5	USP AT	2004/08/ 12 15:33	

Claim 34

Microolithography System



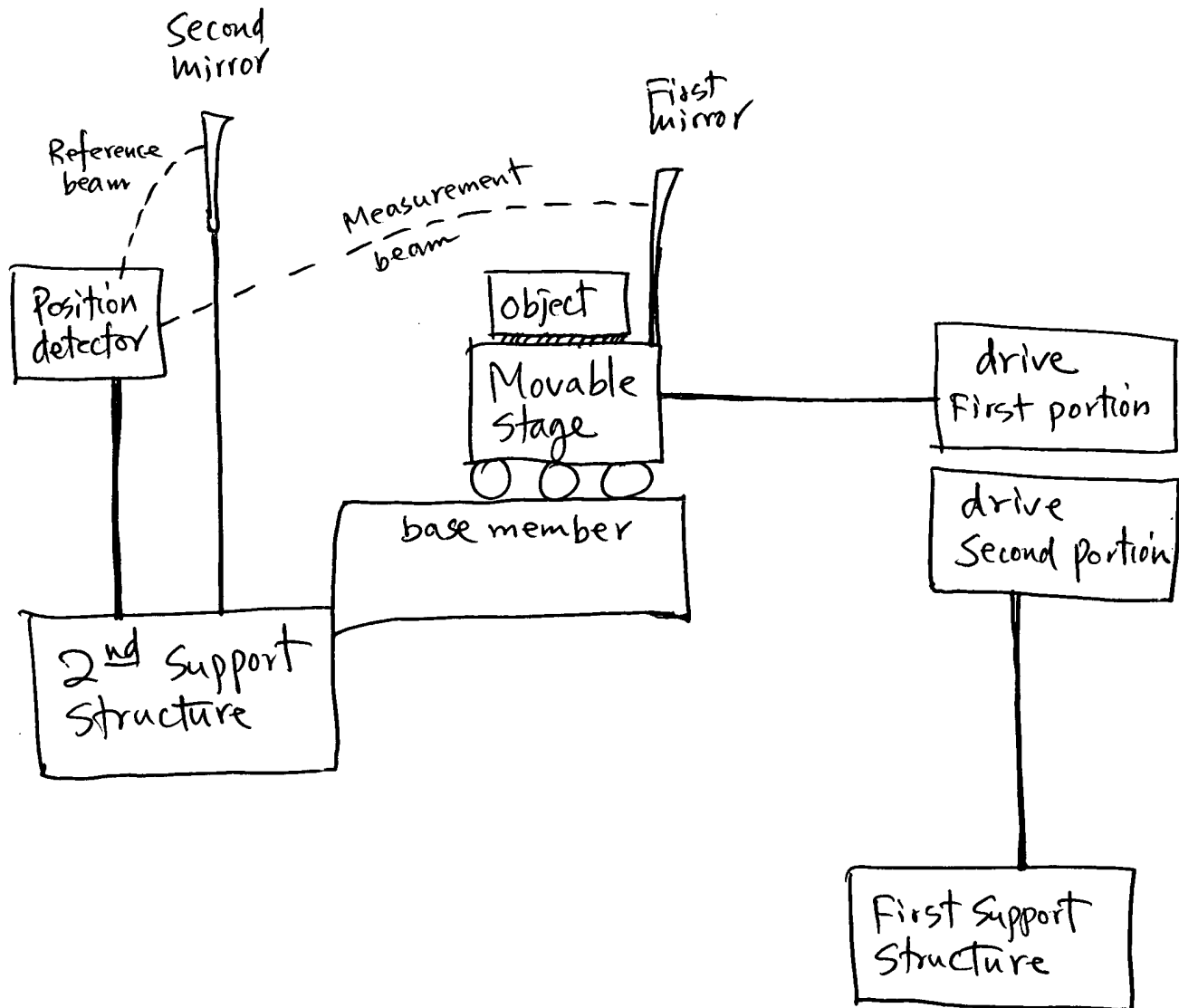
Claim 72



broader than 34

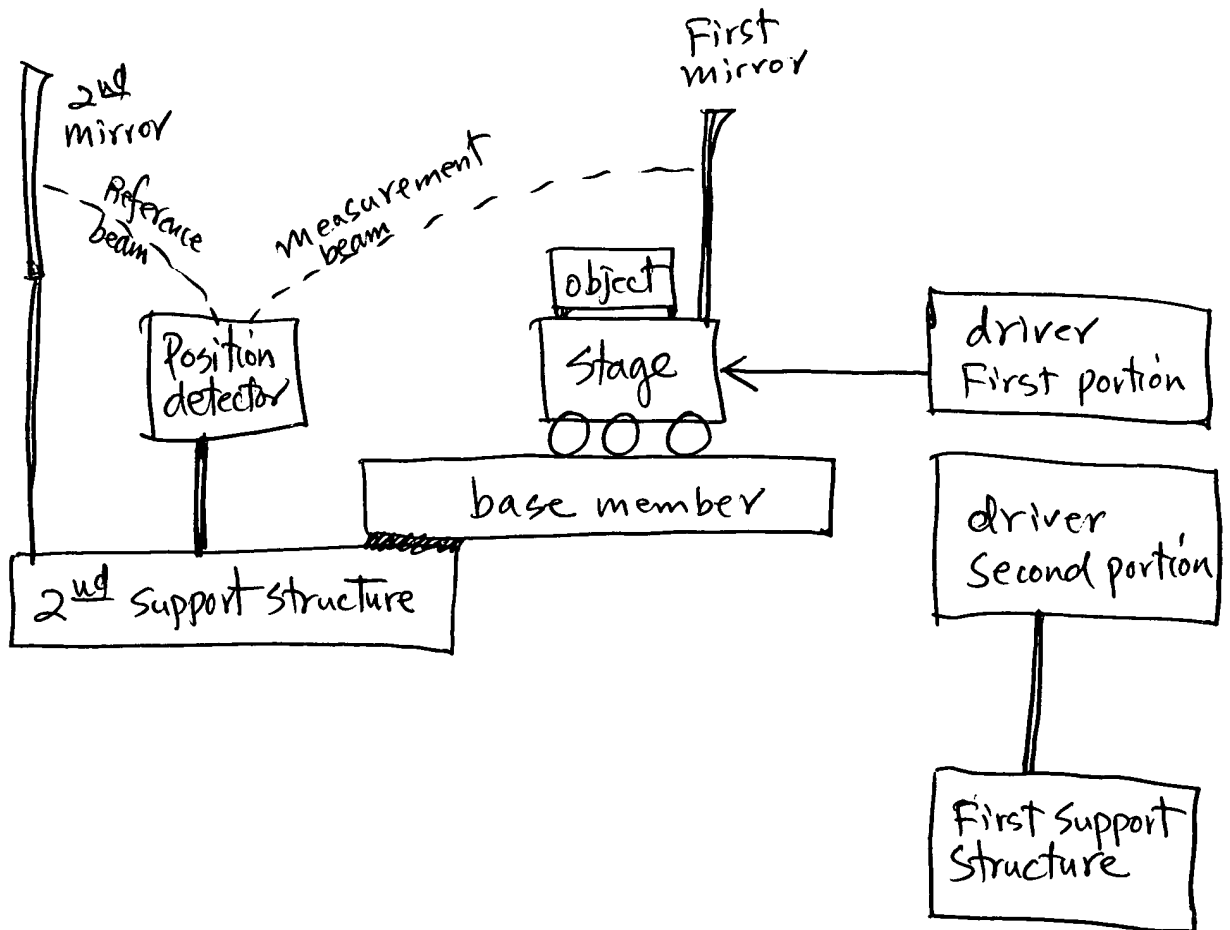
S.N. 880,859

Claim 104 Positioning Apparatus



claim 133

S.N. 880,859



S.N. 880,859

Claim 158

